

Form PTO-1449

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IN AN APPLICATION

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Document Number (Specimen)

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Application Number

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Applicant

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Group Art Unit

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
SPB	6564113	5/13/03	Barto et al.	700	99	6/15/01
SPB	6470227	10/22/02	Rangachari et al.	700	95	12/2/98
SPB	6259959	7/10/01	Martin	700	99	9/4/98
SPB	6128588	10/3/00	Chacon	703	6	10/1/97
SM	5826238	10/20/98	Chen et al.	705	8	4/2/96
W	5768133	6/16/98	Chen et al.	364	468.01	3/19/96

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Part/Port Pages, Etc.)

M	"Understanding the Fundamentals of Kanban and Conway Pull Systems Using Simulation", Marek, et al., Proceedings of the 2001 Winter Simulation Conf., pp. 921-929, found on the web site www.informs-cs.org, 6/12/03.

EXAMINER

DATE CONSIDERED

3/17/06

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